



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Mitsushi FUJIKI**

Group Art Unit: **2823**

Application Number: **10/772,253**

Examiner: **Thanh V. Pham**

Filed: **February 6, 2004**

Confirmation Number: **6491**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE  
INCLUDING A LOW-TEMPERATURE LOWER ELECTRODE-  
FORMING STEP**

Attorney Docket Number: **042068**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

December 28, 2007

Sir:

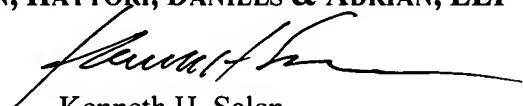
Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 28, 2007 for one month(s) from November 28, 2007 to December 28, 2007.

Attached please find a check in the amount of \$120.00 for the cost of the extension.

If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

  
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